OIPE JC185 AUG 12 2005 PATENT & TRADEMARK OFFICE

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Docket No.:0756-7210

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Hirotada OISHI)
Serial No. 10/684,416) Group Art Unit: 1725
Filed: October 15, 2003) Examiner: S. Heinrich
For: LASER IRRADIATION APPARATUS)
AND METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE BY USING THE
LASER IRRADIATION APPARATUS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on August 10, 2005

Penny L Russi

SECOND REQUEST FOR STATUS

Honorable Commissioner of Patents
P. O. Box 1450
Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

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